

Electronic Patent Application Fee Transmittal				
Application Number:	10577314			
Filing Date:	28-Apr-2006			
Title of Invention:	Substrate cleaning method, substrate cleaning apparatus and computer readable recording medium			
First Named Inventor/Applicant Name:	Hiromitsu Nanba			
Filer:	Michael A. Makuch/Cynthia Johnson			
Attorney Docket Number:	33082M312			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				810